

SON-2192

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Patent Application of

Koji KIKUCHI

Application No. 09/939,773

Filed: August 28, 2001

For: MANUFACTURING METHOD OF A
PHASE SHIFT MASK, METHOD OF
FORMING A RESIST PATTERN AND
MANUFACTURING METHOD OF A
SEMICONDUCTOR DEVICE



Attn: Applications Branch

PETITION TO EXTEND TIME FOR RESPONSE
TO WITHIN THE FIRST EXTENDED MONTH

Commissioner for Patents
Washington, D.C. 20231

Sir:

The applicant, through its attorneys, hereby petitions to extend time for response to the Notice To File Missing Parts Of Nonprovisional Application of September 28, 2001 to within the first extended month. The Commissioner is authorized to charge \$110.00 to Deposit Account 18-0013 to cover the petition fee for a large entity.

The Commissioner is hereby authorized to charge any additional fees associated with this communication or credit any overpayment to Deposit Account No. 18-0013. A duplicate copy of this letter is enclosed for that purpose.

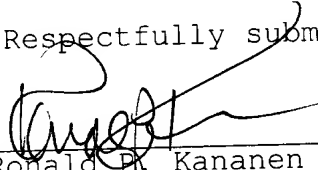
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DATE: December 5, 2001

RADER, FISHMAN & GRAUER, PLLC
Lion Building
1233 20th Street, N.W.
Washington, D.C. 20036
Tel: (202) 955-3750
Fax: (202) 955-3751
Customer No. 23353

Respectfully submitted,



Ronald P. Kananen
Registration No. 24,104